

Cold Atmospheric Plasma Treatment of Tooth Enamels for Bonding Enhancement with Self-Etch Adhesive

Jingwen Tan¹, Yong Wang², Qingsong Yu¹

¹Department of Mechanical and Aerospace Engineering, University of Missouri-Columbia, Columbia, MO 65211, USA

²Department of Oral and Craniofacial Sciences, University of Missouri-Kansas City, Kansas City, MO 64108, USA

Abstract: The plasma treatment effects of tooth enamels were studied on their bonding performance with mild self-etch adhesive. Findings demonstrate that plasma treatment enhanced the interface bonding after 6-month immersion in 37°C de-ionized (DI) water, and reduced the micro-leakage (ML) after 1,000 thermal cycles in 5°C and 55°C DI water baths.

1. Introduction

Several contemporary adhesive systems have been used to achieve adequate immediate bonding strength for resin-based composite dental restorations. However, the higher failure rates in resin composite restorations are mainly caused by the inferior bonding between adhesive resins and the surrounding tooth structure [1, 2]. In mild self-etch adhesive systems, no pre-etching treatment is typically required [3, 4]. However, with self-etch adhesives, the bonding between composite and enamel is usually unsatisfied because the enamel surface is not sufficiently “wet” for composite resin bonding [5]. Hence, applying phosphoric acid prior to mild self-etch adhesive on enamel (also named “selective-etching”) is often used to increase the wettability of cavity enamel margins, which was reported only had a slight positive effect on marginal integrity [6]. Therefore, there is a need to improve the resin-enamel bonding performance.

This study evaluated the effectiveness of plasma treatment for improving interfacial bonding performance between mild self-etch adhesive and tooth enamel.

2. Methods

Plasma treatment of bovine incisor enamels was performed using a cold atmospheric argon plasma brush [7]. Micro-tensile bonding strength (μ TBS) and micro-leakage (ML) tests were conducted to evaluate the enamel-adhesive bonding longevity performance. Three experimental groups of “Unetched” (self-etching), “Etched” (selective-etching) and “Unetched/Plasma-treated” were assigned in these tests.

3. Results and Discussion

Table 1 summarizes the μ TBS test results and failure modes (cohesive, mixed and interfacial failure). From the μ TBS results, significant difference was observed among the groups of *Unetched* (38.2 ± 11.8 MPa), *Etched* (43.8 ± 8.8 MPa) and *Unetched/plasma-treated* (52.2 ± 10.5 MPa) (One-way ANOVA Tukey’s test, $p < 0.01$). Considering the mean strength values, *Unetched/plasma-treated* samples exhibited significant bonding performance than the other two groups. Furthermore, the *Unetched/plasma-treated* enamel presented the lowest interfacial failure percentage and the highest mixed and cohesive failure percentage, which suggested that much stronger adhesive-enamel interfacial bonding was obtained. After 1000 5°C/55°C thermal cycles, the *Unetched*, *Etched* and *Unetched/plasma-treated* restorative teeth displayed a dye

Table 1. μ TBS test results and fracture surface analyses after 6-month immersion in 37 °C DI water.

Characteristic Factors	Unetched	Etched	Unetched/ Plasma-Treated
Tooth Number	8	8	8
Number of Micro-Bars	87	89	107
Bonding Strength (MPa)	38.8 ± 11.8	$43.8 \pm 8.8^*$	$52.2 \pm 10.5^{**}$
Cohesive Failure (%)	18.4	20.2	22.4
Mixed Failure (%)	52.9	55.1	68.3
Interfacial Failure (%)	28.7	24.7	9.3

* with significant difference from Unetched group;

** with significant difference from both the Unetched and the Etched groups.

penetration score of 62, 38, and 22 respectively. The lower of the dye penetration score indicates less ML.

4. Conclusion

This study demonstrated that argon plasma treatment improved enamel-adhesive (all-in-one mild self-etch) bonding longevity performance. Higher bonding strength and less ML were observed in the plasma-treated samples than other groups. The mechanistic study confirmed that plasma treatment enhanced adhesive-enamel bonding, induced higher degree of conversion for the adhesive monomers, and reduced water sorption and resin solubility of adhesive layer. These results indicated plasma treatment improved the mild self-etch adhesive-enamel bonding interface quality and adhesive layer stability, consequently improving the durability of adhesive bonding to enamel.

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